



Substitute for form 1449A/PTO
**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**
(Use as many sheets as necessary)

Complete if Known

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| Application Number | 10/028001 |
| Filing Date | December 20, 2001 |
| First Named Inventor | Forbes, Leonard |
| Group Art Unit | 2818 |
| Examiner Name | Ho, Tu-Tu |

Sheet 1 of 1

Attorney Docket No: 1303.035US1

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| Examiner Initial * | USP Document Number | Publication Date | Name of Patentee or Applicant of cited Document | Class | Subclass | Filing Date If Appropriate |
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| TH | US-6,586,797 | 07/01/2003 | Forbes, Leonard , et al. | 257 | 325 | 08/30/2001 |

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OTHER DOCUMENTS -- NON PATENT LITERATURE DOCUMENTS

| Examiner Initials* | Cite No ¹ | Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published. | T ⁴ |
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EXAMINER

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DATE CONSIDERED

April 2004